PTO/SB/08A (08-03)

Approved for use through 07/31/2006. OMB 0651-0031

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Polyction Act 08/395, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449/PTO

Sheet

Signature

Second Supplemental

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Complete if Known				
Application Number	09/682,329	-		
Filing Date	August 21, 2001			
First Named Inventor	Frank Olschewski			
Art Unit	2624			
Examiner Name	Do, Anh Hong			
Attorney Docket Number	21295.39 (H5236US)			

6/12

DZ

			U. S. PATENT D		
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevan
		Number-Kind Code ^{2 (F known)}			Figures Appear
		US-			
		US-			
		US-		··· ·· · · · · · · · · · · · · · · · ·	
		US-			
		US-			
		US-		· · · · · · · · · · · · · · · · · · ·	
		US-			
		US-			
		US-			
		US-	 		
		US-			
		US-	<u> </u>		
		US-			<u> </u>
		US-	†		
		US-			
		US-	1	<u> </u>	
		US-			
		US-	†		
		US-	+		+

Examiner	Cite	FORE Foreign Patent Document	IGN PATENT DOCL Publication	IMENTS Name of Patentee or	Pages, Columns, Lines,	
Initials*	No.1	Country Code ³ Number ⁴ Kind Code ⁵ (if known)	Date MM-DD-YYYY	Applicant of Cited Document	Where Relevant Passages Or Relevant Figures Appear	۲
AT)		DE19902625A1	09-30-1999	Leica Microsystems	GOIJ 3/42	7
1		DE4330347A1	03-16-1995	Leica Lasertechnik	GOIT 3/36	Г
1		DE19959184A1	06-15-2000	Shimadzu Corp.	G02 B 21/50	Г
		EP0740179A1	10-30-1996	Fondazione Centro	G02B 21/26	Γ
١		WO95/07447	03.16.1995	Leica Lasertechnik	Abstract Only	
AD		GB2346755	08.16.2000	Shimadzu Corporation	Abstract Only HOAR	79
Examiner	T	2 1		Date	0/12/2-/	尸

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. *Applicant's unique citation designation number (optional). *See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. *Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). *For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. *Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. *Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2.